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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Alex Ka Tim Poon, et al.

Application No.: 10/623,004

Filed: July 17, 2003

Title: SYSTEM AND METHOD FOR
MEASURING DISPLACEMENT OF A
STAGE

Attorney Docket No.:PA0585-US/11269.60

Group Art Unit:
2851

Examiner:
Della J. Rutledge

REQUEST FOR CORRECTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Petitioner hereby requests a correction in the Filing Receipt of the above-referenced patent application. Enclosed is a copy of the Filing Receipt with the changes noted thereon.

Respectfully submitted,

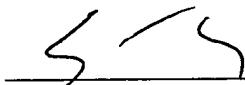
January 5, 2006
Date


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CERTIFICATE OF MAILING UNDER 37 CFR § 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Commissioner for Patents, P.O Box 1450, Alexandria, Virginia, 22313-1450, on this 5th day of January, 2006.


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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY.DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/623,004	07/17/2003	2878 2851	1740	PA0362-US / 11269.60 PA0505-45	13	61	6

CONFIRMATION NO. 4132

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FILING RECEIPT



OC000000011061067

RECEIVED OCT 22 2003

Date Mailed: 10/20/2003

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Applicant(s)

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Domestic Priority data as claimed by applicant**Foreign Applications**

If Required, Foreign Filing License Granted: 10/17/2003

Projected Publication Date: 01/20/2005

Non-Publication Request: No

Early Publication Request: No

Title

System and method for measuring displacement of a stage

Preliminary Class

250

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